



**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application No.: 10/674,292  
Filing Date: September 29, 2003  
Applicant: Hironori Hasei et al.  
Group Art Unit: 1734  
Examiner: Yewebdar T. Tadesse  
Title: METHOD FOR FORMING THIN FILM PATTERN, THIN FILM  
MANUFACTURING DEVICE, CONDUCTIVE THIN FILM WIRING,  
ELECTRO-OPTIC DEVICE, ELECTRONIC APPARATUS, AND  
NON-CONTACT CARD MEDIUM  
Attorney Docket: 9319G-000567

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Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

**AMENDMENT AND PETITION FOR EXTENSION OF TIME**

Sir:

In response to the Office Action mailed December 22, 2004, please amend the application as follows and consider the remarks set forth below.

Applicant hereby petitions under the provisions of 37 C.F.R. § 1.136(a) for an extension of time in which to respond to the outstanding Office Action and includes a fee as set forth in 37 C.F.R. § 1.17(a) with this response for such extension of time.

**Amendments to the Claims** begin on page 2 of this paper.

**Remarks** begin on page 3 of this paper.